SMD-0.2 (CERAMIC LID)

100V, N-CHANNEL

₹TECHNOLOGY



RADIATION HARDENED POWER MOSFET SURFACE MOUNT (SMD-0.2 CERAMIC LID)

Product Summary

Part Number	Radiation Level	RDS(on)	I _D
IRHNMC9A7120	100 kRads (Si)	$55 \mathrm{m}\Omega$	23A
IRHNMC9A3120	300 kRads (Si)	55m Ω	23A

Features

- Low Rds(on)
- Fast Switching
- Single Event Effect (SEE) Hardened
- Low Total Gate Charge
- Simple Drive Requirements
- Hermetically Sealed
- Ceramic Package
- Light Weight
- Surface Mount
- ESD Rating: Class 1C per MIL-STD-750, Method 1020

Description

IR HiRel R9 technology provides superior power MOSFETs for space applications. These devices have improved immunity to Single Event Effect (SEE) and have been characterized for useful performance with Linear Energy Transfer (LET) up to 90MeV/(mg/cm²). Their combination of low RDS(on) and faster switching times reduces the power losses and increases power density in today's high speed switching applications such as DC-DC converters and motor controllers. These devices retain all of the well established advantages of MOSFETs such as voltage control, fast switching, and temperature stability of electrical parameters.

Absolute Maximum Ratings

Pre-Irradiation

Symbol	Parameter	Value	Units
I _{D1} @ V _{GS} = 12V, T _C = 25°C	Continuous Drain Current	23	
I _{D2} @ V _{GS} = 12V, T _C = 100°C	Continuous Drain Current	14	Α
I _{DM} @T _C = 25°C	Pulsed Drain Current ①	92	
P _D @T _C = 25°C	Maximum Power Dissipation	54	W
	Linear Derating Factor	0.43	W/°C
V _{GS}	Gate-to-Source Voltage	± 20	V
E _{AS}	Single Pulse Avalanche Energy ②	392	mJ
I _{AR}	Avalanche Current ①	23	Α
E _{AR}	Repetitive Avalanche Energy ①	5.4	mJ
dv/dt	Peak Diode Recovery dv/dt ③	14.6	V/ns
T _J	Operating Junction and	-55 to + 150	
T _{STG}	Storage Temperature Range	-55 10 + 150	°C
	Lead Temperature	300 (for 5s)	
	Weight	0.25 (Typical)	g

For Footnotes, refer to the page 2.



Electrical Characteristics @ Tj = 25°C (Unless Otherwise Specified)

Symbol	Parameter	Min.	Тур.	Max.	Units	Test Conditions
BV _{DSS}	Drain-to-Source Breakdown Voltage	100			V	$V_{GS} = 0V, I_{D} = 1.0mA$
$\Delta BV_{DSS}/\Delta T_{J}$	Breakdown Voltage Temp. Coefficient		0.1		V/°C	Reference to 25°C, I _D = 1.0mA
R _{DS(on)}	Static Drain-to-Source On-Resistance			55	mΩ	V _{GS} = 12V, I _{D2} = 14A ④
$V_{GS(th)}$	Gate Threshold Voltage	2.0		4.0	V	V V 1 050 A
$\Delta V_{GS(th)} / \Delta T_J$	Gate Threshold Voltage Coefficient		-7.7		mV/°C	$V_{DS} = V_{GS}$, $I_D = 650 \mu A$
Gfs	Forward Transconductance	8.0			S	V _{DS} = 15V, I _{D2} = 14A ④
I _{DSS}	Zara Cata Valtaga Prain Current			1.0		$V_{DS} = 80V, V_{GS} = 0V$
	Zero Gate Voltage Drain Current			10	μA	$V_{DS} = 80V, V_{GS} = 0V, T_{J} = 125^{\circ}C$
I _{GSS}	Gate-to-Source Leakage Forward			100	nA	V _{GS} = 20V
	Gate-to-Source Leakage Reverse			-100	шА	$V_{GS} = -20V$
Q_{G}	Total Gate Charge			23		I _{D1} = 23A
Q_{GS}	Gate-to-Source Charge			9.0	nC	V _{DS} = 50V
Q_GD	Gate-to-Drain ('Miller') Charge			9.0		V _{GS} = 12V
t _{d(on)}	Turn-On Delay Time			10		$V_{DD} = 50V$
tr	Rise Time			14		I _{D1} = 23A
t _{d(off)}	Turn-Off Delay Time			29	ns	$R_G = 7.5\Omega$
t _f	Fall Time			7.5		V _{GS} = 12V
Ls +L _D	Total Inductance		6.8		nH	Measured from center of Drain pad to center of Source pad
C _{iss}	Input Capacitance		1180			V _{GS} = 0V
C _{oss}	Output Capacitance		310		рF	V _{DS} = 25V
C _{rss}	Reverse Transfer Capacitance		1.2			f = 1.0MHz
R _G	Gate Resistance		1.5		Ω	f = 1.0MHz, open drain

Source-Drain Diode Ratings and Characteristics

Symbol	Parameter		Тур.	Max.	Units	Test Conditions	
Is	Continuous Source Current (Body Diode)			23	۸		
I _{SM}	Pulsed Source Current (Body Diode) ①			92	Α		
V _{SD}	Diode Forward Voltage			1.2	V	$T_J = 25^{\circ}C, I_S = 23A, V_{GS} = 0V$	
t _{rr}	Reverse Recovery Time	165 ns T _J = 25		$T_J = 25^{\circ}C, I_F = 23A, V_{DD} \le 25V$			
Q _{rr}	Reverse Recovery Charge	945 nC di/dt = 100A/µs @		di/dt = 100A/µs ④			
t _{on}	Forward Turn-On Time	Intrinsic turn-on time is negligible (turn-on is dominated by $L_S + L_D$)					

Thermal Resistance

Symbol	Parameter	Min.	Тур.	Max.	Units
$R_{ heta JC}$	Junction-to-Case			2.3	°C/W

Footnotes:

- ① Repetitive Rating; Pulse width limited by maximum junction temperature.
- $^{\circ}$ V_{DD} = 25V, starting T_J = 25°C, L = 4.0mH, Peak I_L = 14A, V_{GS} = 20V
- $\ensuremath{ \Im } \quad I_{SD} \leq \ 23A, \ di/dt \leq 1800A/\mu s, \ V_{DD} \leq 100V, \ T_J \leq 150 \ensuremath{^{\circ}C}$
- \odot Total Dose Irradiation with V_{GS} Bias. 12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MIL-STD-750, Method 1019, condition A.
- \odot Total Dose Irradiation with V_{DS} Bias. 80 volt V_{DS} applied and V_{GS} = 0 during irradiation per MIL-STD-750, Method 1019, condition A.



Radiation Characteristics

IR HiRel Radiation Hardened MOSFETs are tested to verify their radiation hardness capability. The hardness assurance program at IR HiRel is comprised of two radiation environments. Every manufacturing lot is tested for total ionizing dose (per notes 5 and 6) using the TO-3 package. Both pre- and post-irradiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison.

Table1. Electrical Characteristics @ Tj = 25°C, Post Total Dose Irradiation \$6

Symbol	Parameter	Up to 300	kRads (Si) 1	Units	Test Conditions	
Symbol	i diametei	Min.	Max.	Office	rest conditions	
BV _{DSS}	Drain-to-Source Breakdown Voltage	100		V	$V_{GS} = 0V, I_{D} = 1.0mA$	
V _{GS(th)}	Gate Threshold Voltage	2.0	4.0	V	$V_{DS} = V_{GS}$, $I_D = 650\mu A$	
I _{GSS}	Gate-to-Source Leakage Forward		100	nA	V _{GS} = 20V	
I _{GSS}	Gate-to-Source Leakage Reverse		-100	nA	V _{GS} = -20V	
I _{DSS}	Zero Gate Voltage Drain Current		1.0	μA	$V_{DS} = 80V, V_{GS} = 0V$	
R _{DS(on)}	Static Drain-to-Source ④ On-State Resistance (TO-3)		60	mΩ	V _{GS} = 12V, I _{D2} = 14A	
R _{DS(on)}	Static Drain-to-Source ④ On-State Resistance (SMD-0.2)		55	mΩ	V _{GS} = 12V, I _{D2} = 14A	
V _{SD}	/ _{SD} Diode Forward Voltage		1.2	V	V _{GS} = 0V, I _S = 23A	

^{1.} Part numbers IRHNMC9A7120 and IRHNCM9A3120

IR HiRel radiation hardened MOSFETs have been characterized in heavy ion environment for Single Event Effects (SEE). Single Event Effects characterization is illustrated in Fig. a and Table 2.

Table 2. Typical Single Event Effect Safe Operating Area

LET	F	Danas		VDS	S (V)	
LET (MeV/(mg/cm ²))	Energy (MeV)	Range (µm)	@ VGS = 0V	@ VGS = -1V	@ VGS = -5V	@ VGS = -10V
37 ± 5%	417 ± 7.5%	50 ± 7.5%	100	100	100	100
59.8 ± 5%	753 ± 7.5%	60 ± 7.5%	100	100	100	100
89.8 ± 5%	1515 ± 7.5%	82 ± 7.5%	100	100		

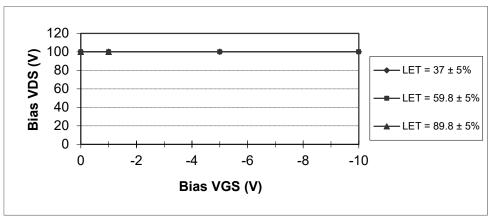


Fig a. Typical Single Event Effect, Safe Operating Area

For Footnotes, refer to the page 2.

Pre-Irradiation

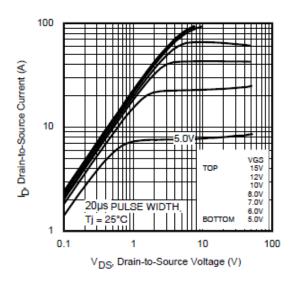


Fig 1. Typical Output Characteristics

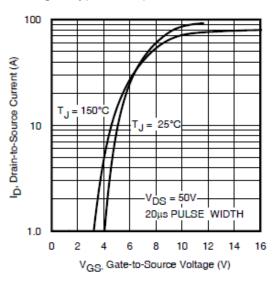


Fig 3. Typical Transfer Characteristics

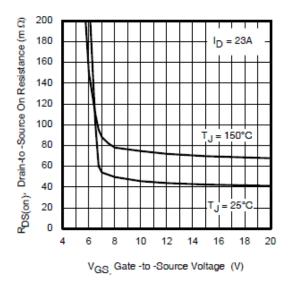


Fig 5. Typical On-Resistance Vs Gate Voltage

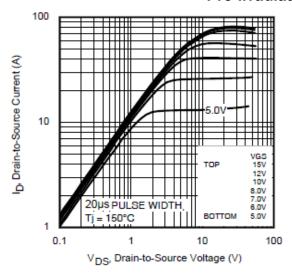


Fig 2. Typical Output Characteristics

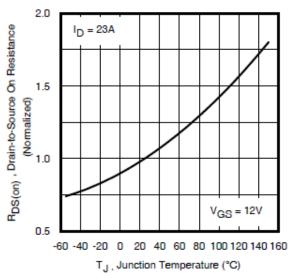


Fig 4. Normalized On-Resistance Vs. Temperature

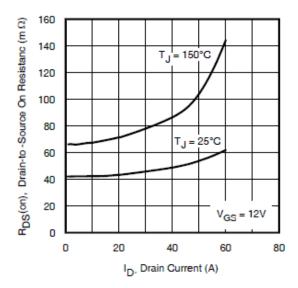


Fig 6. Typical On-Resistance Vs Drain Current

Pre-Irradiation

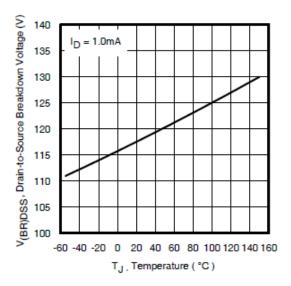


Fig 7. Typical Drain-to-Source Breakdown Voltage Vs Temperature

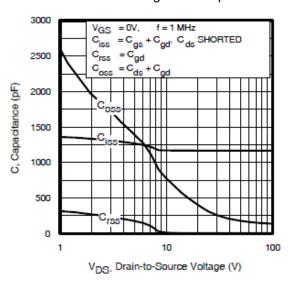


Fig 9. Typical Capacitance Vs. Drain-to-Source Voltage

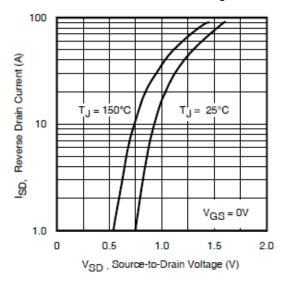


Fig 11. Typical Source-Drain Diode Forward Voltage

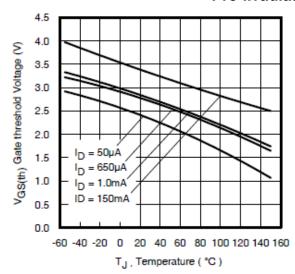


Fig 8. Typical Threshold Voltage Vs Temperature

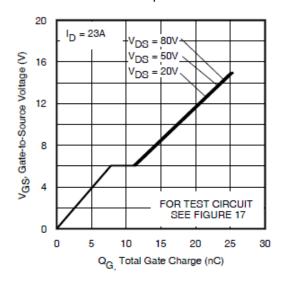


Fig 10. Typical Gate Charge Vs. Gate-to-Source Voltage

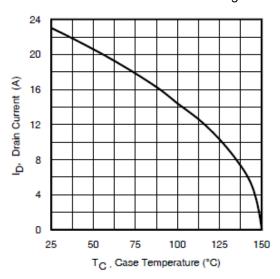
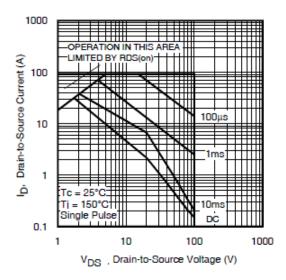


Fig 12. Maximum Drain Current Vs. Case Temperature





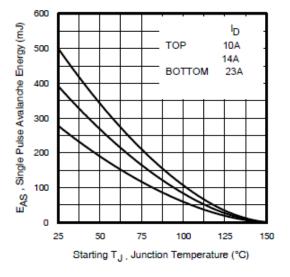


Fig 13. Maximum Safe Operating Area

Fig 14. Maximum Avalanche Energy Vs. Drain Current

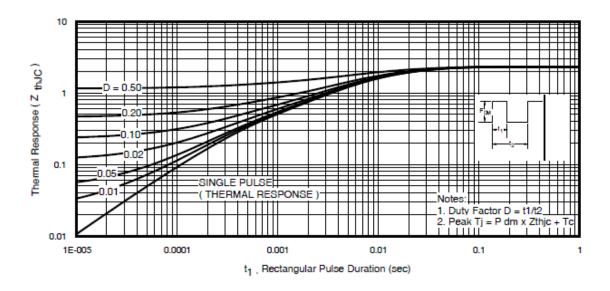


Fig 15. Maximum Effective Transient Thermal Impedance, Junction-to-Case



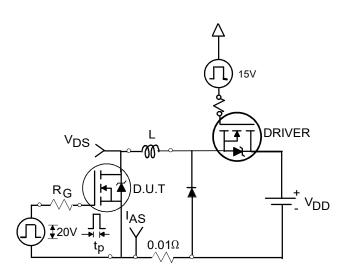


Fig 16a. Unclamped Inductive Test Circuit

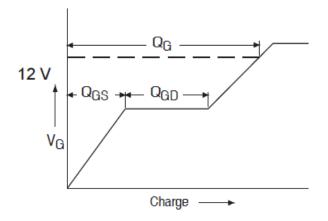


Fig 17a. Gate Charge Waveform

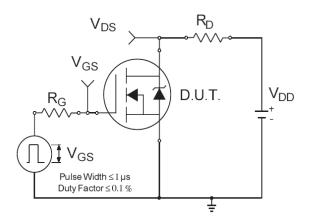


Fig 18a. Switching Time Test Circuit

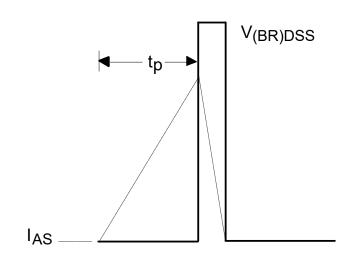


Fig 16b. Unclamped Inductive Wave-

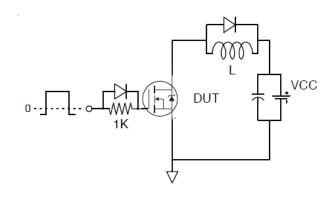


Fig 17b. Gate Charge Test Circuit

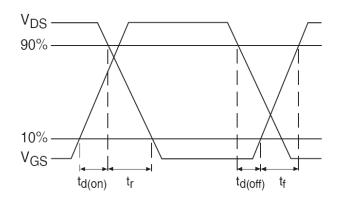
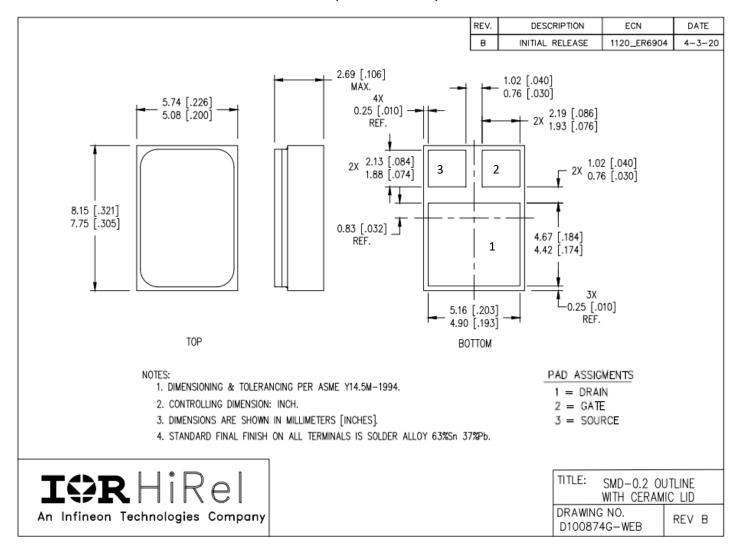


Fig 18b. Switching Time Waveforms



Note: For the most updated package outline, please see the website: SMD-0.2 (Ceramic Lid)

Case Outline and Dimensions — SMD-0.2 (Ceramic Lid)





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